

Electronic Patent Application Fee Transmittal

Application Number:	10549859			
Filing Date:	06-Jun-2006			
Title of Invention:	Plasma film-forming method and plasma film-forming apparatus			
First Named Inventor/Applicant Name:	Yasuo Kobayashi			
Filer:	Michael A. Makuch/Cynthia Johnson			
Attorney Docket Number:	033082M280			
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
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Extension - 3 months with \$0 paid	1253	1	1110	1110

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Total in USD (\$)				1110